

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|------------------------|------------------|---------|------------------|
| S1 | 3 | c23c016\$.ipc. and (dry\$3 with heat\$3 with compress\$3 with air) | US-PGPUB; USPAT | OR | ON | 2004/09/29 16:54 |
| S2 | 1 | c23c016\$.ipc. and (dry\$3 with heat\$3 with compress\$3 with air) | EPO; JPO; DERWENT | OR | ON | 2004/09/29 16:55 |
| S3 | 10 | "118"/\$.ccls. and (dry\$3 with heat\$3 with compress\$3 with air) | US-PGPUB; USPAT | OR | ON | 2004/09/29 16:55 |
| S4 | 5 | (wafer substrate workpiece semiconductor) and (clean\$3 wash\$3) and (dry\$3 with heat\$3 with compress\$3 with air) | EPO; JPO; DERWENT | OR | ON | 2004/09/29 16:55 |
| S5 | 5 | (wafer substrate workpiece semiconductor) and (clean\$3 wash\$3) and (dry\$3 with heat\$3 with compress\$3 with air) | EPO; JPO; DERWENT | OR | ON | 2004/09/29 16:58 |
| S6 | 97 | (wafer substrate workpiece semiconductor) and (clean\$3 wash\$3) and (dry\$3 with heat\$3 with compress\$3 with air) | US-PGPUB; USPAT | OR | ON | 2004/09/29 16:56 |
| S7 | 11 | (wafer substrate workpiece semiconductor) same (clean\$3 wash\$3) same (dry\$3 with heat\$3 with compress\$3 with air) | US-PGPUB; USPAT | OR | ON | 2004/09/29 16:56 |
| S8 | 1775 | ((118/719) or (414/939) or (156/345.31) or (156/345.32)).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/05/31 11:03 |
| S9 | 289 | ((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and ((wash\$3 clean\$3) same (dry\$3 heat\$3) same (etch\$3 deposit\$3 coat\$3)) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:18 |
| S10 | 25 | ((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and ((wash\$3 clean\$3) same (dry\$3 heat\$3) same (etch\$3 deposit\$3 coat\$3))) and 118/718.ccls. | US-PGPUB; USPAT | OR | ON | 2005/05/13 18:02 |
| S11 | 3 | "5356474".URPN. | USPAT | OR | ON | 2003/09/26 16:13 |
| S12 | 22 | ((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and ((wash\$3 clean\$3) with (solution fluid)) same (dry\$3 heat\$3) same (etch\$3 deposit\$3 coat\$3)) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:34 |
| S13 | 0 | ((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and (brush\$3 same rins\$3 same ultrasonic\$3) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:20 |
| S14 | 148 | brush\$3 same rins\$3 same ultrasonic\$3 | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:20 |
| S15 | 3 | (brush\$3 same rins\$3 same ultrasonic\$3) and ("118"/\$.ccls. 156/345.\$ccls.) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:21 |
| S16 | 11 | ("1289507" "3294576" "3367791" "3429741" "3473955" "3535157" "3589975" "3756196" "4004045" "4114563" "4154193").PN. | USPAT | OR | ON | 2003/09/26 16:26 |
| S17 | 1 | ((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and (air with knife with (plural\$3 multiple)) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:36 |
| S18 | 39 | ("118"/\$.ccls. 156/345.\$ccls.) and (air with knife with (plural\$3 multiple)) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:36 |
| S19 | 0 | (c23c016\$.ipc.) and (air with knife with (plural\$3 multiple)) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 16:38 |
| S20 | 26 | "4370356".URPN. | USPAT | OR | ON | 2003/09/26 16:36 |
| S21 | 1 | (c23c016\$.ipc.) and (air with knife.) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 18:38 |
| S22 | 48 | (air with knife with (plural\$3 multiple)) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 16:47 |
| S23 | 0 | ((air with knife with (ion\$5))) and ((air with knife with (heat\$3))) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 16:47 |
| S24 | 13 | (air with knife with (ion\$5)) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 16:50 |
| S25 | 0 | ((air with knife with (ion\$5))) and (((118/719) or (414/939) or (156/345.31) or (156/345.32)).CCLS.) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:51 |
| S26 | 3 | ((air with knife with (ion\$5))) and ("118"/\$.ccls. 156/345.\$ccls.) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:51 |

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| S27 | 142 | (air with knife with (heat\$3)) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 16:57 |
| S28 | 1 | ("4017982").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2003/09/26 16:57 |
| S29 | 212 | ((((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and (load with lock\$3 with chamber) and (clean\$3 with chamber) | US-PGPUB; USPAT | OR | ON | 2003/09/26 16:59 |
| S30 | 41 | ((((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and (load with lock\$3 with chamber with heat\$3) and (clean\$3 with chamber) | US-PGPUB; USPAT | OR | ON | 2003/09/26 17:12 |
| S31 | 79 | kondo-masataka\$.in. hayashi-katsuhiko.in. kuribe-eiji.in. | US-PGPUB; USPAT | OR | ON | 2003/09/26 17:13 |
| S32 | 17 | (kondo-masataka\$.in. hayashi-katsuhiko.in. kuribe-eiji.in.) and (clean\$3 wash\$3 rins\$3) | US-PGPUB; USPAT | OR | ON | 2003/09/26 17:19 |
| S33 | 3 | ((("6103442") or ("5587226") or ("5501744")).PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2003/09/26 17:19 |
| S34 | 2 | ("10209477").PN. | USOCR; JPO; DERWENT | OR | OFF | 2003/09/26 17:20 |
| S35 | 60 | (air with knife with (ion\$5)) | US-PGPUB; USPAT | OR | ON | 2003/09/26 18:16 |
| S36 | 611 | (c23c016\$.ipc.) and ((film layer coat\$3) and ((material process) with gas.) and (inert with gas)) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 18:39 |
| S37 | 69 | (c23c016\$.ipc.) and ((film layer coat\$3) and ((material process) with gas) and (inert with gas) and pipe) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 18:39 |
| S38 | 22 | (c23c016\$.ipc.) and ((film layer coat\$3) and ((material process) with gas) and (inert with gas) and pipe and plasma) | EPO; JPO; DERWENT | OR | ON | 2003/09/26 18:39 |
| S42 | 306 | (air with knife with angl\$3) | US-PGPUB; USPAT | OR | ON | 2005/05/13 17:31 |
| S43 | 44 | (air with knife with angl\$3) same (substrate wafer semiconductor workpiece) | US-PGPUB; USPAT | OR | ON | 2005/05/13 17:32 |
| S44 | 1 | ("3935041").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2005/05/13 17:35 |
| S45 | 5 | ("5762749").URPN. | USPAT | OR | ON | 2005/05/13 17:36 |
| S46 | 2 | ("4077137" "5115926").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2005/05/13 17:40 |
| S47 | 2 | ("6073369").URPN. | USPAT | OR | ON | 2005/05/13 17:41 |
| S48 | 6 | ("4408400" "4779355" "5068977" "5147690" "5212877" "6158141").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2005/05/13 17:44 |
| S49 | 10 | ("4832759" "5083226" "5171996" "5266141" "5372312" "5419733" "5498444" "5529829" "5730637" "5760502").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2005/05/13 17:47 |
| S50 | 26 | (((((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and ((wash\$3 clean\$3) same (dry\$3 heat\$3) same (etch\$3 deposit\$3 coat\$3))) and 118/718.ccls. | US-PGPUB; USPAT | OR | ON | 2005/05/13 18:02 |
| S51 | 1 | ("5762749").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/05/31 11:03 |